

## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Ikuhito ONODERA

Application No.: 10/076,653

Filed: February 19, 2002 Docket No.: 111984

For: METHOD FOR FABRICATING A THIN FILM MAGNETIC HEAD AND WAFER

STRUCTURE

## **INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. English-language Abstracts of the non-English language references 1-2 are attached hereto.

3. A computer-generated English translation of the following Japanese reference(s) has been obtained from the website of the Japanese Patent Office ([http://www.jpo.go.jp]), and is attached, but has not been reviewed for accuracy. See References 1-2.

Respectfully submitted,

James A. Olik Registration No. 27,075

Joel S. Armstrong Registration No. 36,430

JAO:JSA/bms

Date: August 24, 2004

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INFORMATION DISCLOSURE STATEMENT										
(Use several sheets if necessary)			APPLICANT(S) Ikuhito ONODERA							
				FILING DATE February 19, 2002						
U.S. PATENT DOCUMENTS										
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Date: August 24, 2004